

Handwritten initials and date: 4/18/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Leskela et al.

Appl. No. : 09/787,062

Filed : June 28, 2001

For : METHOD FOR GROWING
OXIDE THIN FILMS
CONTAINING BARIUM AND
STRONTIUM

) Group Art Unit 1765

)

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April 11, 2003

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)

Andrew N. Merickel, Reg. No. 53,317

Examiner : Matthew A. Anderson

RESPONSE TO FINAL OFFICE ACTIONUnited States Patent and Trademark Office
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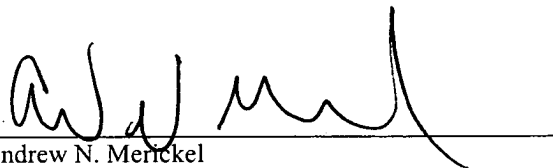
APR 16 2003

TC 1700

Dear Sir:

In response to the Final Office Action mailed on February 19, 2003, Applicants respectfully request entry of the following amendments and consider the subsequent remarks. The amendments and remarks do not raise new issues or require extensive consideration by the Examiner and are believed to place the application in condition for allowance.

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- (X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.
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